

JCO9 Rec'd PCT/PTO 08 MAY 2001 #3
09/062985

10191/1690

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of : Becker et al.
International Application No. : PCT/DE00/01835
International Filing Date : June 6, 2000
U.S. Serial No. : 09/762,985
For : **DEVICE AND METHOD FOR ETCHING A
SUBSTRATE USING AN INDUCTIVELY
COUPLED PLASMA**

Assistant Commissioner for Patents
Box PCT
Washington, D.C. 20231

Attention: DO/EO/US

**RESPONSE TO MISSING REQUIREMENTS
UNDER 35 U.S.C. 371**

S I R :

In response to the Notification of Missing Requirements Under 35 U.S.C. 371 in the United States Designated/Elected Office (DO/EO/US) (mailed March 12, 2001), Applicants submit herewith Figures 3 and 4 of the drawings with English text. A copy of the Notification of Missing Requirements is enclosed.

The Office is authorized to charge the \$130.00 fee to cover the late processing fee and any additional fees to Kenyon & Kenyon Deposit Account No. 11-0600.

Applicants request a one month extension of time to respond to the Notification Of Missing Requirements mailed March 12, 2001, resetting the response date to May 12, 2001. The extension fee of \$110.00 should be charged to Kenyon & Kenyon Deposit Account No. 11-0600.

Respectfully submitted,
KENYON & KENYON

05/10/2001 HNGUYEN 00000123 110600 09762985

01 FC:154 130.00 CH
02 FC:115 110.00 CH

Date:

5/8/01

Richard L. Mayer

My. Mary C. Muenner Reg no. 30, 333

Richard L. Mayer, Reg. No. 22,490

One Broadway
New York, NY 10004
Tel: (212) 425-7200
Fax: (212) 425-5288

EXPRESS MAIL NO.: EL245834518US

09/762985

EXPRESS MAIL CERTIFICATE

"EXPRESS MAIL" MAILING LABEL NUMBER 8224583451845DATE OF DEPOSIT 5/8/01TYPE OF DOCUMENT Response to Missing RequirementsSERIAL NO. 09/762,985 FILING DATE 6/6/2000

~~I HEREBY CERTIFY THAT THIS PAPER OR FEE IS BEING DEPOSITED~~
WITH THE UNITED STATES POSTAL SERVICE "EXPRESS MAIL POST
OFFICE TO ADDRESSEE" SERVICE UNDER 37 CFR 1.10 ON THE DATE
INDICATED ABOVE, BY BEING HANDED TO A POSTAL CLERK OR BY
BEING PLACED IN THE EXPRESS MAIL BOX BEFORE THE POSTED
DATE OF THE LAST PICK UP, AND IS ADDRESSED TO THE ASSISTANT
COMMISSIONER FOR PATENTS, WASHINGTON, D.C. 20231.

Chandur Seenanain

(PRINTED NAME OF PERSON MAILING PAPER OR FEE)

Chandur Seenanain

(SIGNATURE OF PERSON MAILING PAPER OR FEE)

Device And Method For Etching A Substrate Using An
Inductively Coupled Plasma.